10/797,456 January 17th, 2006 Reply to Office Action of 11/25/2005 Via Facsimile

## Listing of the Claims

This listing of the claims shall replace all previous listings:

- (Currently Amended) Semi-conducting thin sheet wedges comprising:
   a mica matrix, wherein said mica matrix comprises mica flakes; and
   a conductive resin impregnated within said mica matrix;
   wherein said thin sheet wedges have a semi-conductive property of between 500-500,000 ohms per square;
   whereby said semi-conducting thin sheet wedges are thin sheet wedges.
- 2. (Original) The semi-conducting thin sheet wedges of claim 1, wherein said thin sheet wedges have a thickness of between about 15-80 mils (0.38-2.0 mm).
- 3. (Original) The semi-conducting thin sheet wedges of claim 1, wherein said mica flakes comprise at least one of muscovite, phlogopite and combinations thereof.
- 4. (Original) The semi-conducting thin sheet wedges of claim 1, wherein said resin comprises approximately 15-40% by weight of said thin sheet wedges.
- 5. (Original) The semi-conducting thin sheet wedges of claim 1, wherein said resin is C-black.
- 6. (Original) The semi-conducting thin sheet wedges of claim 1, wherein said thin sheet wedges have a tensile modulus of between 1-8 million PSI.
- 7. (Original) The semi-conducting thin sheet wedges of claim 1, wherein said thin sheet wedges further comprises at least one glass fiber layer.
- 8. (Original) The semi-conducting thin sheet wedges of claim 7, wherein the ratio of the mica in said mica matrix to the glass fiber is approximately between 2:1 and 7:1 by weight.
- 9. (Original) The semi-conducting thin sheet wedges of claim 7, wherein said at least one glass fiber layer forms a backing for said mica matrix.
- 10. (Original) The semi-conducting thin sheet wedges of claim 7, wherein said at least one glass fiber layer is interwoven with said mica matrix.

10/797,456 January 17<sup>th</sup>, 2006 Reply to Office Action of 11/25/2005 Via Facsimile

- 11. (Original) The semi-conducting thin sheet wedges of claim 10, wherein said at least one glass fiber layer is interwoven in a half-lap manner.
- 12. (Currently Amended) Semi-conducting thin sheet wedges comprising:
  a mica matrix, wherein said mica matrix comprises mica
  flakes;

at least one layer of glass fiber; and

a conductive resin impregnated within at least one of said mica matrix and said at least one layer of glass fiber;

wherein said thin sheet wedges have a semi-conductive property of between 500-500,000 ohms per square;

wherein said thin sheet wedges have a tensile modulus of between 1-8 million PSI;

whereby said semi-conducting thin sheet wedges are thin sheet wedges.

- 13. (Original) The semi-conducting thin sheet wedges of claim 12, wherein the ratio of the mica in said mica matrix to the glass fiber is approximately between 2:1 and 7:1 by weight.
- 14. (Original) The semi-conducting thin sheet wedges of claim 12, wherein said at Least one glass fiber layer forms a backing for said mica matrix.
- 15. (Original) The semi-conducting thin sheet wedges of claim 12, wherein said at least one glass fiber layer is interwoven with said mica matrix.
- 16. (Original) The semi-conducting thin sheet wedges of claim 15, wherein said at least one glass fiber layer is interwoven in a half-lap manner.
- 17. (Original) The semi-conducting thin sheet wedges of claim 12, wherein said mica flakes comprise at least one of muscovite, phlogopite and combinations thereof.
- 18. (Original) The semi-conducting thin sheet wedges of claim 12, wherein said resin comprises approximately 15-40% by weight of said thin sheet wedges.
- 19. (Original) The semi-conducting thin sheet wedges of claim 12, wherein said resin is C-black.

10/797,456 January 17th, 2006 Reply to Office Action of 11/25/2005 Via Facsimile

20.(Currently Amended) A method for making semi-conductive thin sheet wedges comprising:

layering a mica matrix onto a glass fiber backing, wherein said mica matrix comprises mica flakes;

impregnating into said mica matrix and said glass fiber a conductive resin;

and

curing said conductive resin;

whereby said semi-conducting thin sheet wedges are thin sheet wedges.